



EM-ISight-ER Electromagnetic Scanning System Extended Reach Model



EM-ISight-ER EMI/EMC measurement system built on a 6 axis articulated robot designed to support multiple applications and industries including networking, automotive, integrated circuits, aviation, military, and consumer products. Used as compliance system for IEC-61967-1-6 or a pre-compliance / development tool, the abundance of features meet most requirements for research, design and analytical needs. Custom applications can be developed by the user for EM-ISight-ER allowing for a complete customized test platform. The footprint of the system includes a workstation which allows for integration of the robot and controller. Multiple work space including off axis horizontal and vertical assessments can be conducted. Multiple probe options are available for the system and the ability to upgrade for ESD measurements at a later date provides a fully flexible test platform. Near-field measurements can be executed from 10 kHz to 6GHz as standard with optional upgrade for ESD or frequency extension to 20/40GHz available.

EM-ISight-ER is an affordable and easy to use system with great return on investment when compared to traditional measurement solutions. Using the optional Far Field Approximation (FFA) module is an

alternative to costly pre-compliance EMC chambers which have high maintenance costs and use significant floor space. Integration of high end Low Noise Amplifiers at the core of the transmission line yield low insertion loss and high unwanted field rejection of better than 25dBm. Easy setup for measurement profiles (less than 60 seconds) using the optional camera and touch detection allow complex topologies of a PCB to be taught in real time.

Measurements can be conducted in traditional Cartesian and off axis Horizontal scan configurations.

### Applicable Standards

IEC-61967-1-6 VCCI/CISPR 22/FCC Pt 15/22 EN55022 CISPR 12/FCC Pt 18/EN55011/ EN60555/VDE0871 EN55024/EN6100-6-4/GR-1089-CORE ITU-T/ETS300/ IEC-6100-3

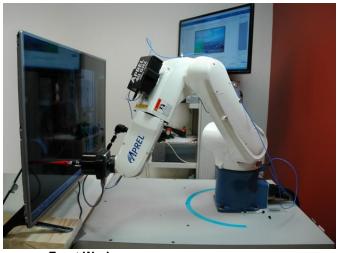
### **Applications**

Integrated Circuit/Printed Circuit Board Wireless modules De-Sense testing (receiver circuits) Medical devices Automotive and aviation Electronic device emissions Pre-Compliance testing (emissions/susceptibility) Quality control/audit Consumer products cell phone/computer devices Susceptibility / ESD

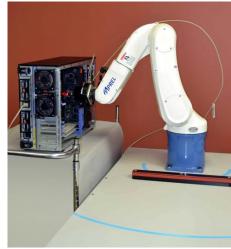
### Supported Spectrum Analyzers

Tektronix Keysight/Agilent Anritsu Rhode and Schwartz

NOTE: Signal generator, spectrum analyzer is customer supplied. Some applications require additional upgrades from a standard package spectrum analyzer; please confirm spectrum analyzer compatibility with APREL.





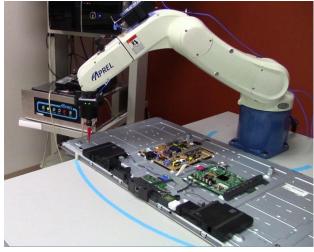


Side Workspace

### **Vertical scans**

## **System Highlights**

- Single probe solution from 10kHz to 6GHz
- X/Y/Z scan areas of 600mm (Cartesian)
- High resolution scan (>0.02mm)
- Coarse scan with dynamic peak search function
- Real-time topology analysis using dynamic touch detection (Cartesian or Horizontal)
- Z height distance from 0.05mm up to 600mm (Cartesian)
- 4D Measurements of DUT by integrating X/Y/Z & Phi
- Field distribution presented in 2D, 3D or 4D plotting with quick snap image processing @ 2.2µm
- Source direction plots (vector)
- · Customizable reports based on user requirements automatically exported to MS Word
- Delta plot measurement function (compare before/after measurements)
- Frequency distribution plots based on span and trace with added limit lines
- AVI export function for real-time visualization of field and frequency distribution
- Advanced measurement functions, single point analysis, quick check, free move and point delta
- Micro Strip Line 10kHz to 6GHz
- Quick scan setup using Optional robot mounted vision camera with 2.2µm pixel size and auto zoom



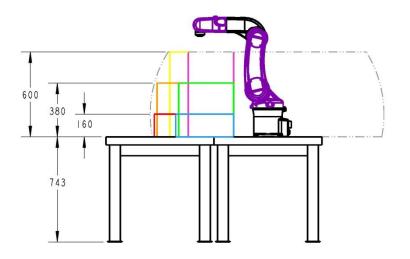
**Front Workspace** 

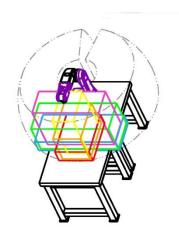


**Horizontal Scans** 

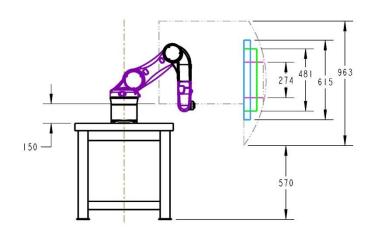
Side workspace

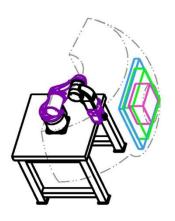
# **Optional Workstation Configurations**

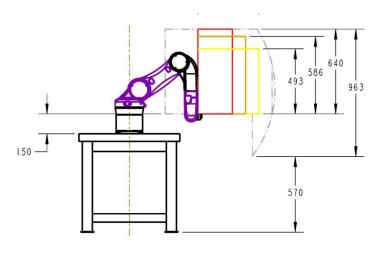


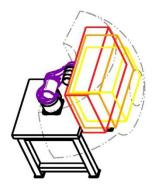


**Horizontal Scan** 









**Vertical Scans** 

### **Standard System Configuration**

- Single probe solution for measurements from 10kHz to 6GHz
- Low Noise Amplifier 10kHz 6GHz
- Calibrated H-Field antenna probe to ISO/IEC-17025 standards to IEC-61967-1-6
- Software platform with 1 year fully comprehensive support and feature updates
- Software supports user defined parametric settings, user defined pass/fail graphing, and graphical
  measurement data for statistical readout full 3/4D graphic package for visualization and manipulation of
  measured fields, storage and retrieval of measurement results
- Automated precision antenna probe movement using DENSO robotics
- Remote access to measurement database
- · Dynamic process control
- Z-Axis surface detection system
- Standard workstation L = 152cm x W = 76cm x H = 30cm
- Collision detection system for user/DUT safety
- Device Positioning fixture

### **Optional Accessories/Software**

Measurement software and probe upgrade to 20/40GHz

E-Field Antenna Probe

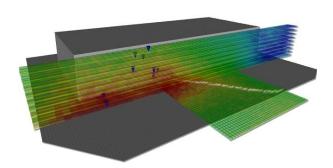
Dual Stage Low Noise Amplifiers DC to 6/20/40 GHz

FFA Far Field Approximation Software

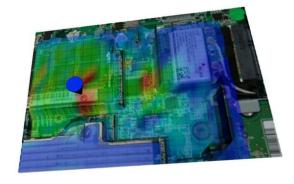
**USA Ubiquitous Server Application** 

Robot mounted vision camera with 2.2µm pixel size and auto zoom

ESD/Susceptibility Test Suite



FFA Tiled Volumes with Hotspot Markers



4D Plot with Interpolated Grid and 3D Hotspot Marker

Description	Perform EM Near-field scanning on a PCB, IC, LCD, RFID tag, wireless module, or antenna's for quality control and design optimization, pre-test and certification		
Software	Windows XP, Vista, 7, 8 an	nd MAC Boot Camp	
	User friendly GUI that allows for easy setup and data retrieval		
	Automatic antenna probe r		
	Automatic system control or user definable parametric setup incorporating optional vision camera		
	Visual display including storage and retrieval of measured results in full 3/4D  Data tracking for project improvement/quality control		
		easurement profiles to track design/quality improvements	
Applications	PCB and IC	ments of (near-field) magnetic fields emitted by a DUT, including RF circuit	
		sing an optional spectrum analyzer and presented in 2D/3D/4D form via PC	
	Typical applications include,		
	EMI noise emission analysis		
		nent/optimization	
	PCB board or IC design optimization/placement		
	Antenna design	9	
		nitted radiation analysis of mobile handset LCD or LCD controllers	
		tibility and ESD test modules	
Typical Probe Measuring Unit	Antenna:	E or H-field with 0.02mm spatial resolution	
Typical Probe Measuring Offic	Typical frequency range:	Frequency sweep, in band discreet value from 10KHz to 40GHz	
	Sensitivity:	Probe Dependent	
	VSWR:	<1:2	
	Input impedance:	50Ω Normalized	
	Linearity:	<0.1dB	
	LNA (standard):	>30dB Preamplifier for EM Measurements from 100kHz to 6GHz	
	LNA (Optional)	Up to 20 GHz or 40 GHz	
	Noise floor:	Measured with micro strip line (-30dBm @ 10kHz	
		-139dB with preamplifier module)	
		Optional GPS Probe >-151dBm @ 1600MHz	
	Measurement Uc:	0.05dBm @ 0.05mm Z and 0.1dBm @ 0.2mm X & Y	
	Optional probes:	Rosenberger Micro-Coax rectangular and small loop and interface	
Measuring Reach and	NO. of axes: 6 (X, Y, Z an		
Movement	Typical reach*:	- · · ·	
	Along X & Y axes:	600 x 600 mm (factory limited Cartesian)	
	Along Z axis:	600mm (Cartesian)	
	Rotation $\theta$ axis:	360°	
	Resolution:		
	X and Y axes:	0.02mm	
	Z axis:	0.02mm	
	θ axis:	0.1°	
	Alignment accuracy:		
	X and Y axes:	0.02mm	
	Z axis:	0.02mm	
	θ axis:	± 1°	
		asurement space (reach) are available.	
DUT Orientation	Typical:	Horizontal	
DOT Orientation	турісат.	Vertical	
		Custom	
System Control	Controller for overall contr	ol: IBM PC compatible machine, Intel i3 or better and 512 RAM	
	Operating system:	Windows XP/Vista/Win 7/8	
	Motor controller:	Denso	
	Measuring interface:	GPIB/LAN/Serial port	
General	Operating requirement:		
	Temperature:	0° C to +60°C	
	humidity:	60% or less	
	AC power input:	Single phase 100V ~ 230V, 50Hz/60Hz*	
	Power consumption:	less than 15A @ 100V	
	Weight:	25kg	
	Dimension:	80cmx50cmx70cm	
Additional Features SW	Multiple plots recorded in s	Multiple layers on single measurement process	
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Additional Features SW	Multiple layers on single m Automated peak search		
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